


<b>Search Notes</b>  	<b>Application/Control No.</b>  10651690	<b>Applicant(s)/Patent Under Reexamination</b>  KIM ET AL.
	<b>Examiner</b>  Michael Szperka	<b>Art Unit</b>  1644

<b>SEARCHED</b>			
<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>

<b>SEARCH NOTES</b>		
<b>Search Notes</b>	<b>Date</b>	<b>Examiner</b>
updated inventor search in eDAN: Kim, Joanne Young Hee Kwak; Beer, Alan E.; Gilman-Sachs, Alice	10/3/08	MS
updated USPAT USPGPUB EPO JPO DERWENT (EAST) see search printouts	10/3/08	MS

<b>INTERFERENCE SEARCH</b>			
<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>

	/Michael Szperka/ Primary Examiner.Art Unit 1644
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